

**Notice of References Cited**

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Applicant(s)/Patent Under  
Reexamination  
OHNISHI, SHINJI

Examiner

LIN LIU

Art Unit

2145

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2004/0133415	07-2004	Rappaport et al.	703/022
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	K	US-			
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	M	US-			

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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**NON-PATENT DOCUMENTS**

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